

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

Kenji YOSHIDA, et al.

Conf.: 3806

Appl. No.:

09/889,392

Group:

2834

Filed:

July 16, 2001

Examiner:

J. GONZALEZ

For:

**ACOUSTIC WAVE APPARATUS** 

## REPLY TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents Washington, DC 20231

October 18, 2002

Sir:

In reply to the Examiner's Office Action dated September 18,, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

## IN THE CLAIMS:

The claims have been amended as follows:

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4. (Amended) An acoustic wave apparatus comprising:

a piezoelectric substrate mainly containing lithium tantalate;

an interdigital transducer including a conductor formed on said substrate; and a reflector including a conductor formed on said substrate,

wherein a surface rotated in a range of 34° to 41° from a crystal Y axis around a crystal X axis of the lithium tantalite is set as a surface of said substrate, a standardized electrode thickness (h/ $\lambda$ ) obtained by standardizing a thickness h of an electrode finger constituting at least a part of said reflector by a wavelength  $\lambda$  of a surface acoustic

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